

**Notice of References Cited**

Application/Control No.

10/577,069

Applicant(s)/Patent Under  
Reexamination  
HATA ET AL.

Examiner

JULIA SLUTSKER

Art Unit

2891

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,040,849 A	08-1977	Greskovich et al.	423/348
*	B	US-6,562,648 B1	05-2003	Wong et al.	438/46
*	C	US-7,547,925 B2	06-2009	Wong et al.	257/103
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Panchula and Ying, "Nanocrystalline Aluminum Nitride: II, sintering and Properties," J.Am.Ceram.Soc., 86, 2003, pp.1121-1127.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.